

Supplementary Materials

Improvement of Alkali Metal Resistance for NH₃-SCR Catalyst Cu/SSZ-13: Tune the Crystal Size

Zexiang Chen ¹, Meiqing Shen ^{1,2}, Chen Wang ^{1,3}, Jianqiang Wang ¹, Jun Wang ^{1,*} and Gurong Shen ^{4,*}

¹ School of Chemical Engineering & Technology, Tianjin University, Tianjin 300072, China; tjuczx@tju.edu.cn (Z.C.); mqshen@tju.edu.cn (M.S.); chenwang87@tju.edu.cn (C.W.); jianqiangwang@tju.edu.cn (J.W.)

² Collaborative Innovation Centre of Chemical Science and Engineering (Tianjin), Tianjin 300072, China

³ School of Environmental and Safety Engineering, North University of China, Taiyuan 030051, China

⁴ School of Materials Science and Engineering, Tianjin University, Tianjin 300350, China

* Correspondence: wangjun@tju.edu.cn (J.W.); gr_shen@tju.edu.cn (G.S.)

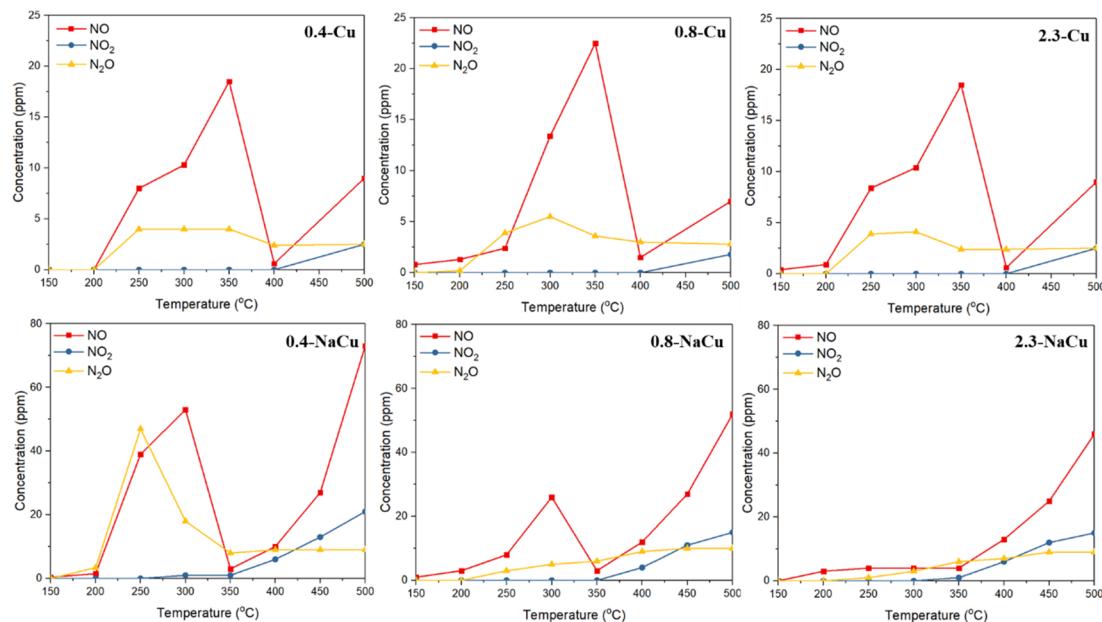


Figure S1. NO_x and N₂O concentration evolution in the NH₃ oxidation.

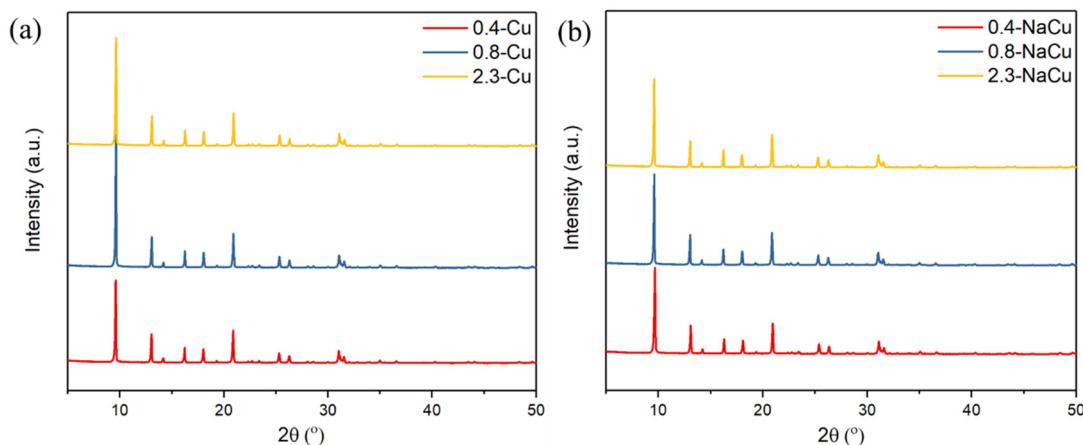
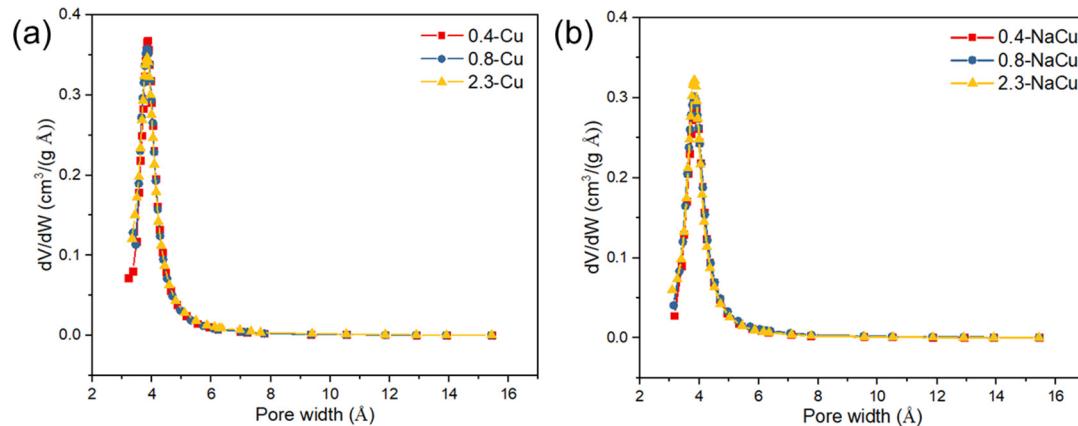
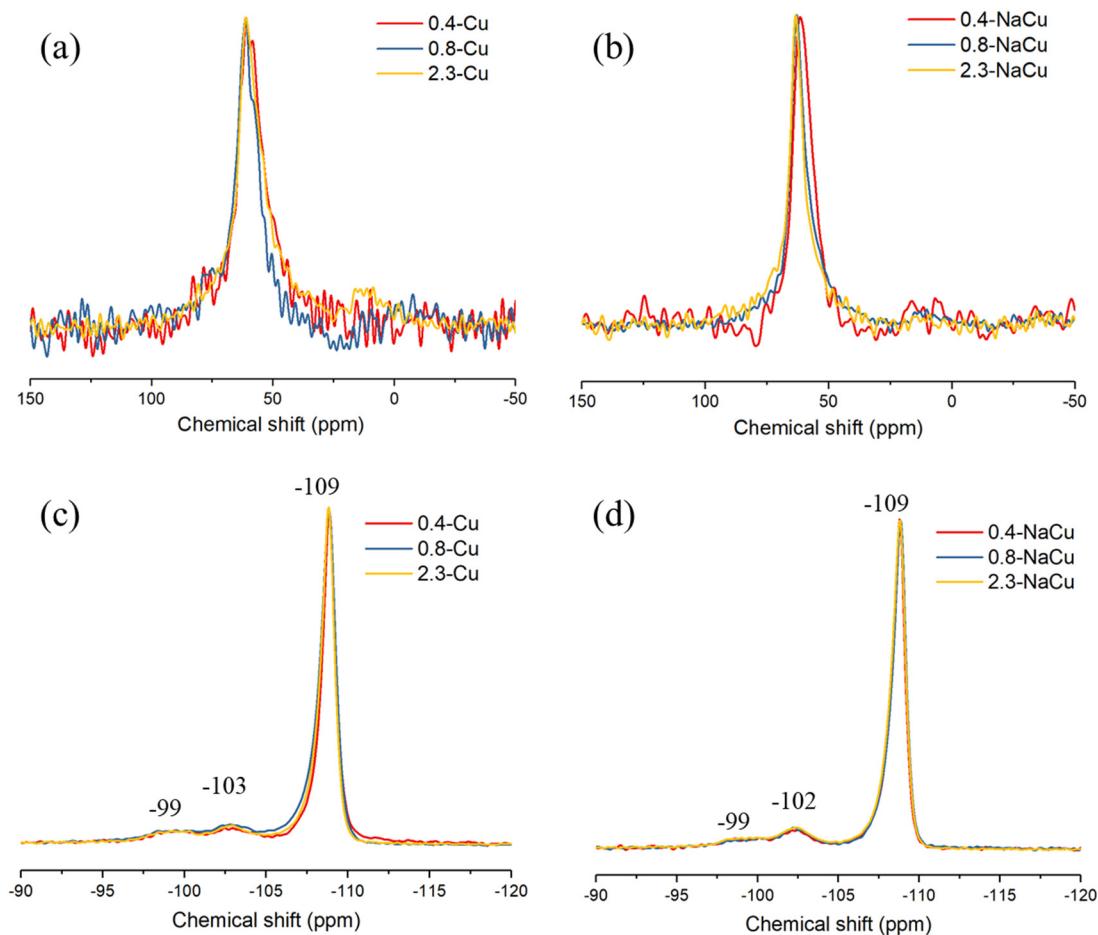


Figure S2. XRD patterns of Cu/SSZ-13 (a) before and (b) after Na poisoning.**Figure S3.** The micropore distribution of Cu/SSZ-13 (a) before and (b) after Na poisoning.**Figure S4.** (a-b) ^{27}Al NMR spectra and (c-d) ^{29}Si NMR spectra of CuSSZ-13 before and after Na poisoning.

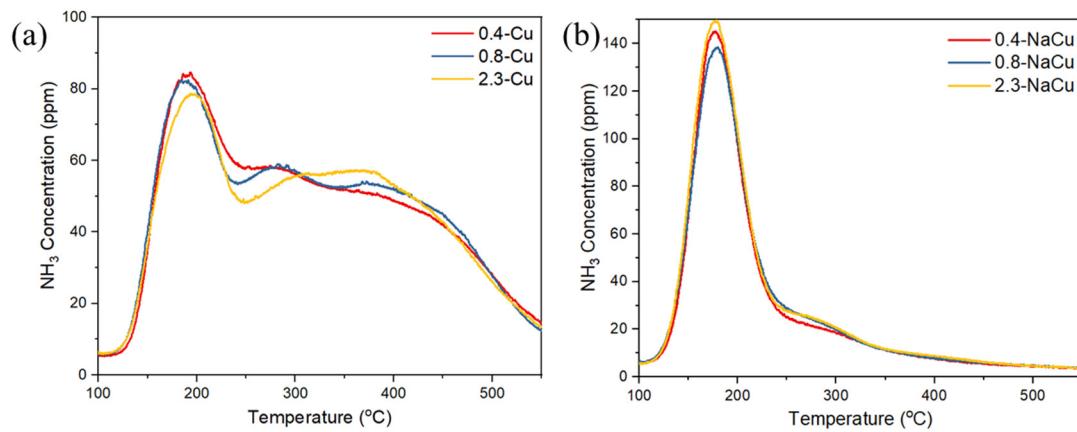


Figure S5. NH_3 -TPD profiles of Cu/SSZ-13 with different crystal sizes (a) before and (b) after Na poisoning.

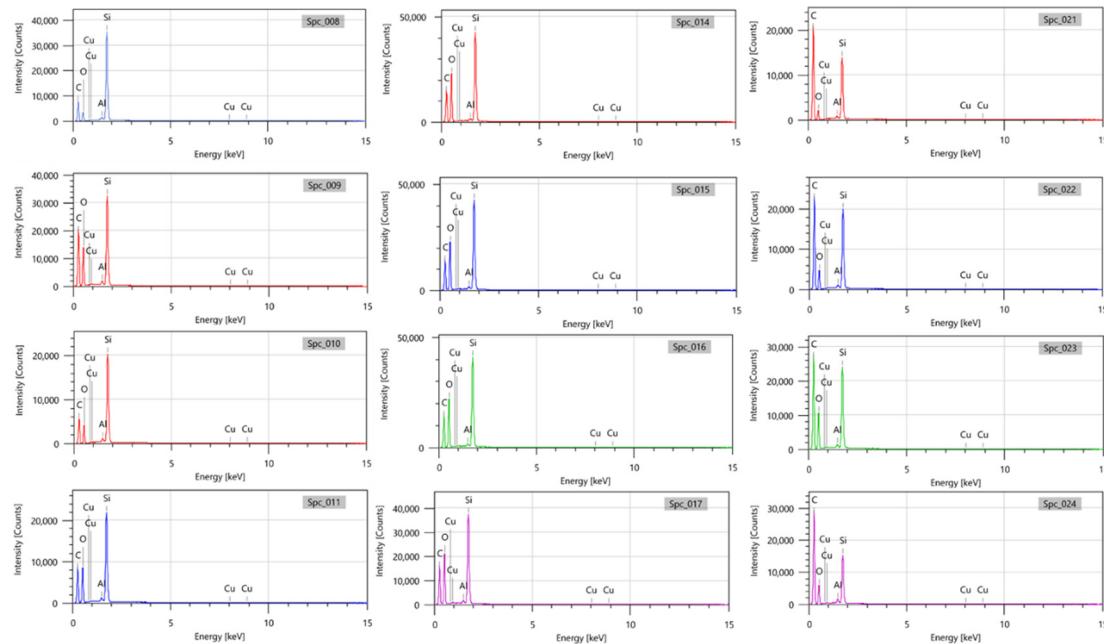


Figure S6. Point EDS spectra corresponding to the results in Figure 9.

Table S1. Element composition of Cu/SSZ-13 and Na-poisoned counterparts with different crystal sizes.

Samples	Si/Al molar ratio ¹	Cu content ² (wt%)	Na ² (wt%)
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0.4-Cu	25.2	1.05	-
0.8-Cu	24.8	1.38	-
2.3-Cu	25.4	1.44	-
0.4-NaCu	-	1.04	2.05
0.8-NaCu	-	1.30	1.97
2.3-NaCu	-	1.36	2.09

1. Si/Al ratio is measured by XRF.

2. Cu and Na contents are measured by ICP.

